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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Volker Haerle
Serial No. : 10/625,118
Filed : July 22, 2003
Title : METHOD OF PRODUCTION OF SEMICONDUCTOR COMPONENTS

Art Unit : 2824
Examiner : Beth E. Owens

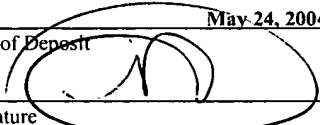
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF FEBRUARY 24, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit May 24, 2004
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